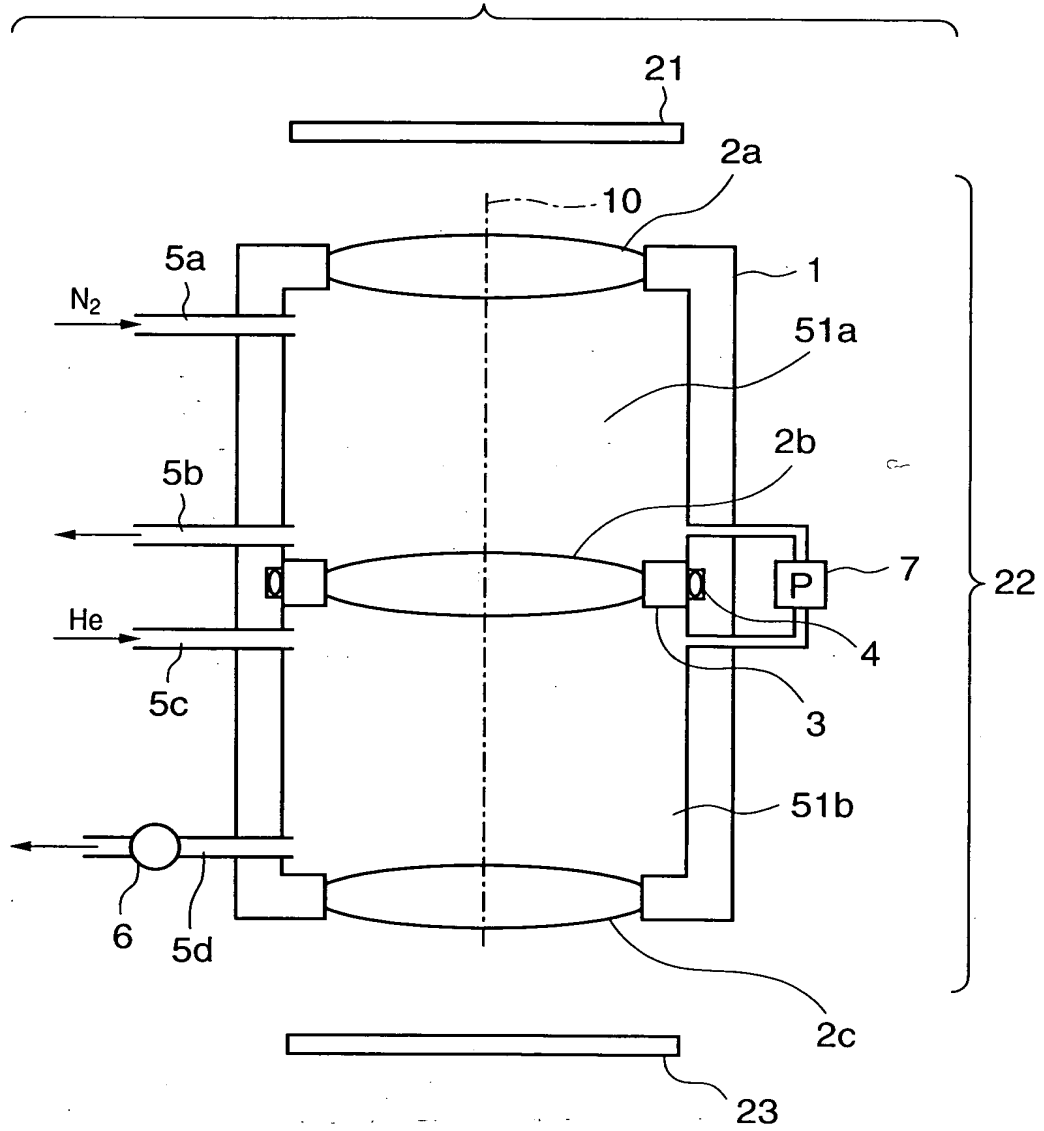


FIG. 1



**FIG. 2**

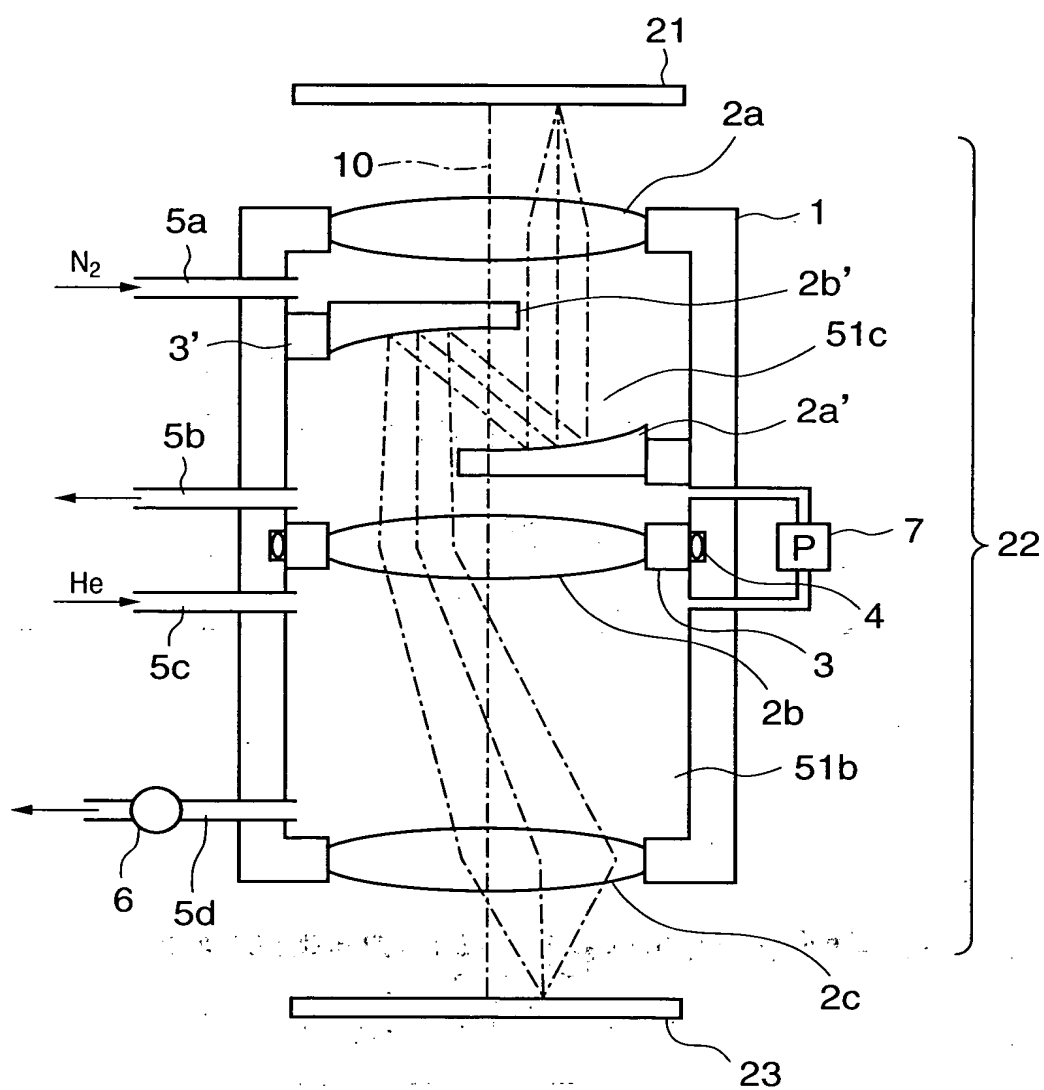
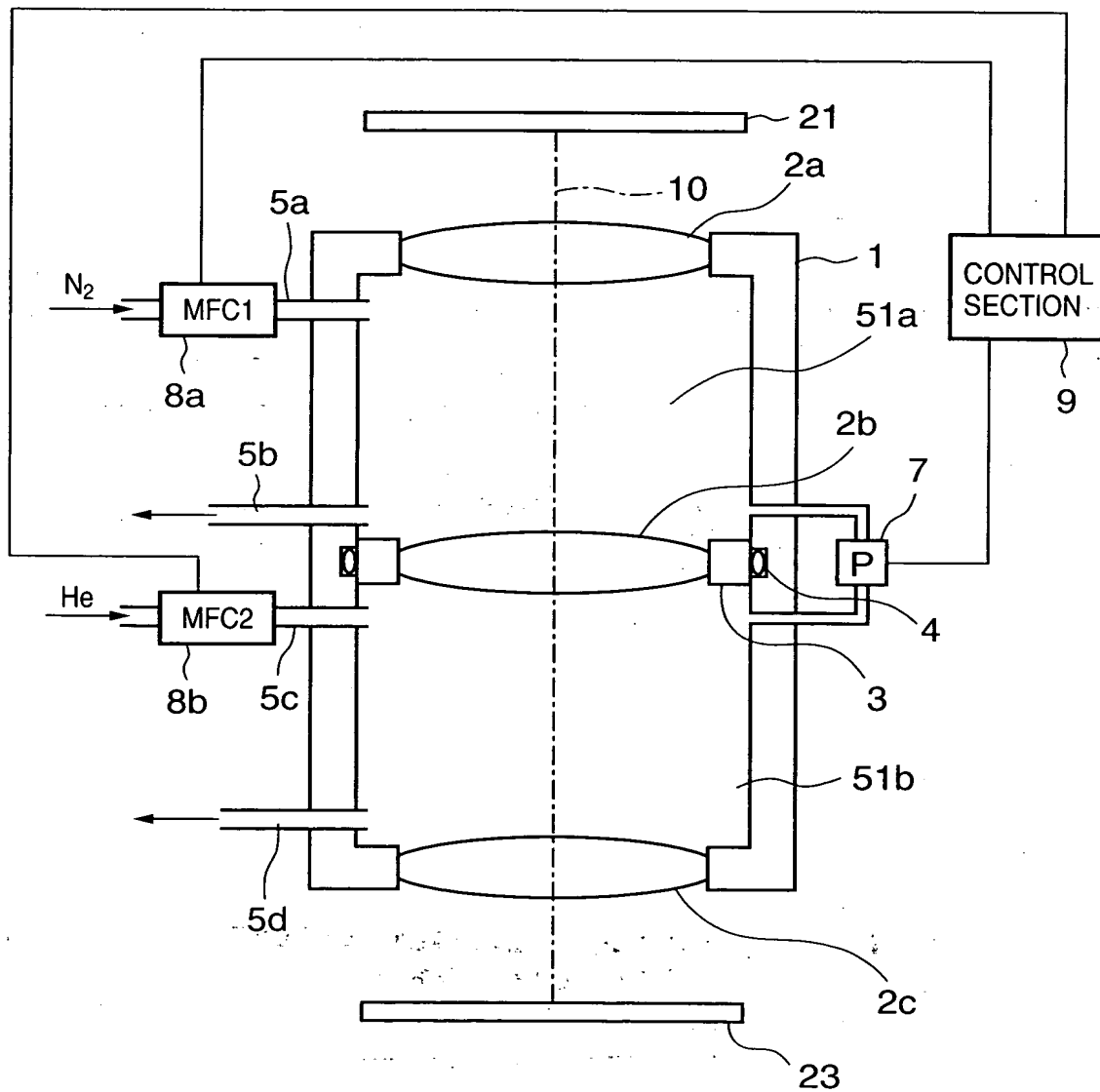
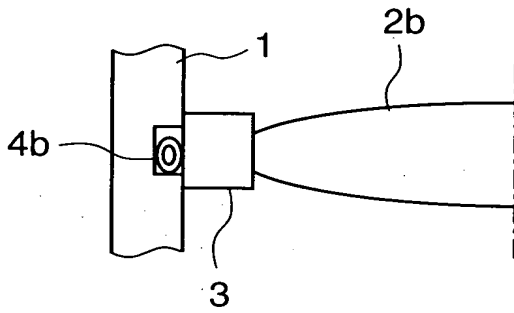


FIG. 3



**FIG. 5**



**FIG. 6**

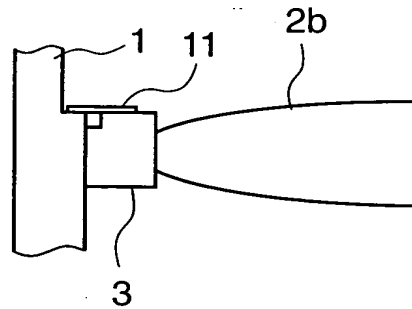
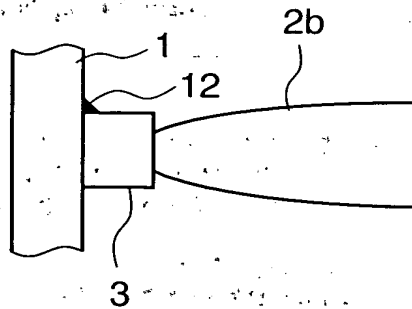


FIG. 7



**FIG. 8**

AIR CONCENTRATION CHANGE IN He SPACE WITH  
RESPECT TO PRESSURE DIFFERENCE BETWEEN SPACES

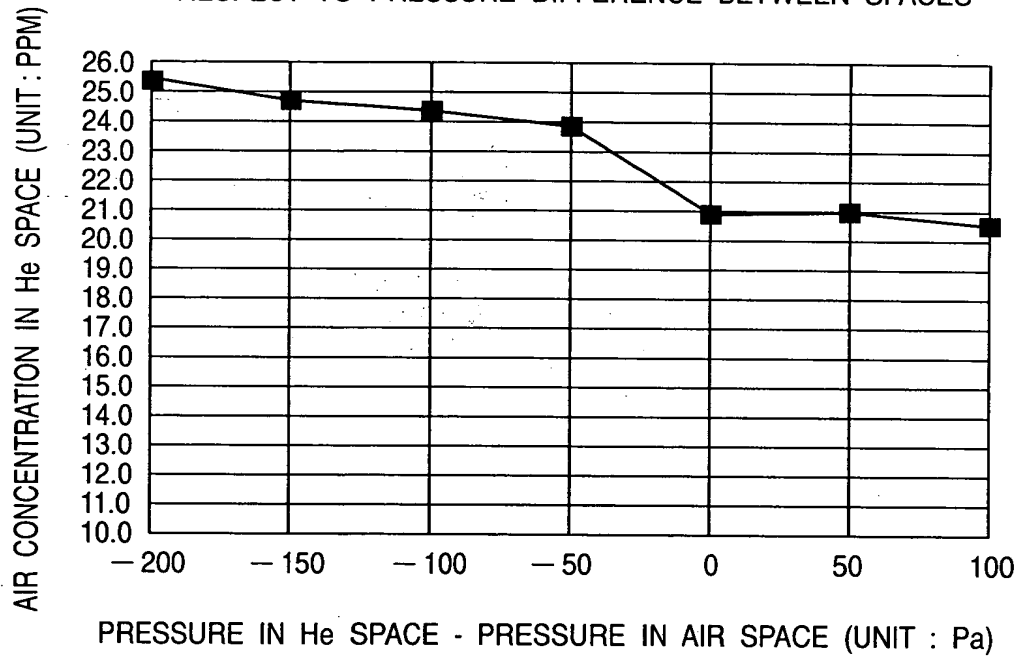


FIG. 9

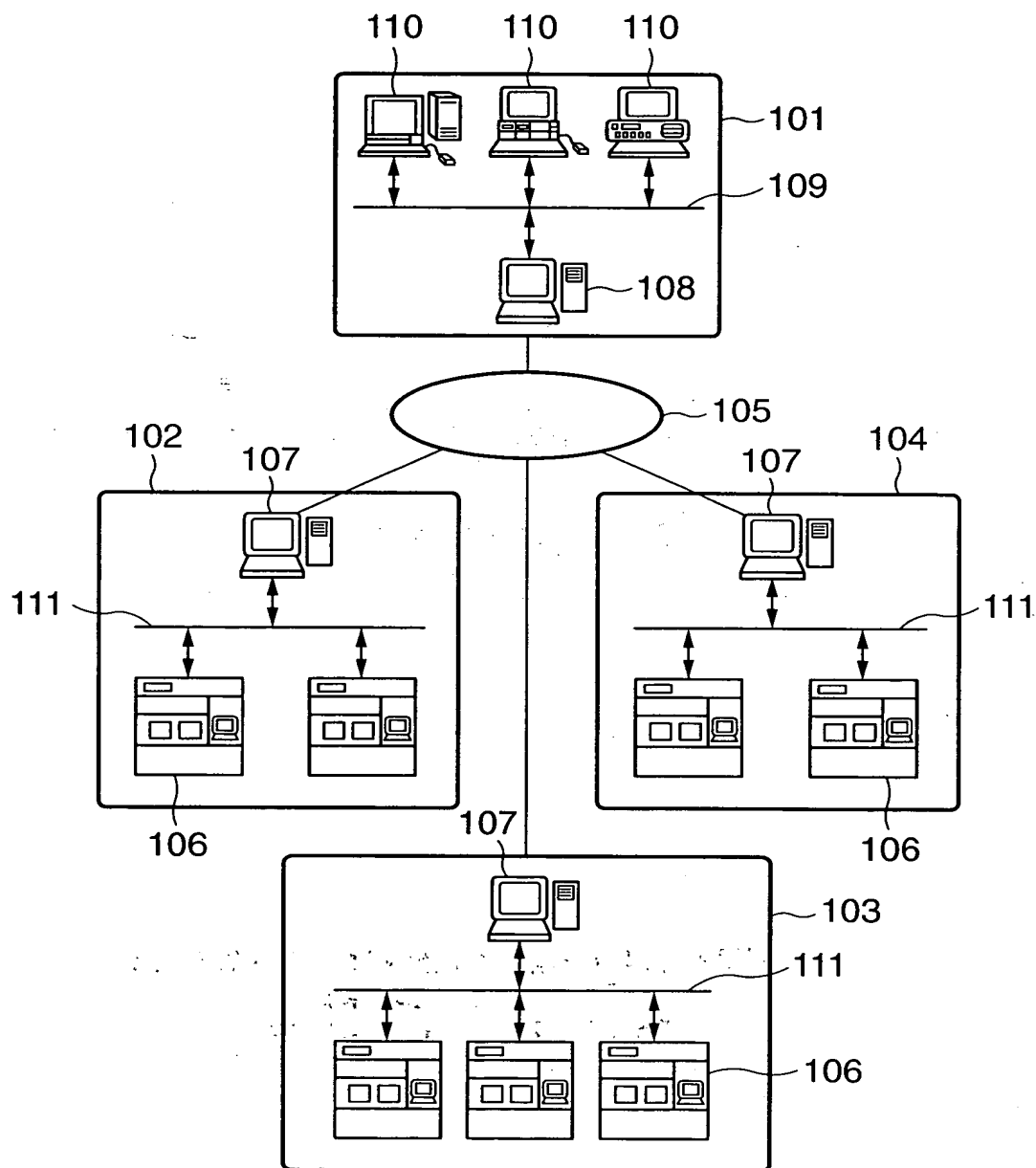
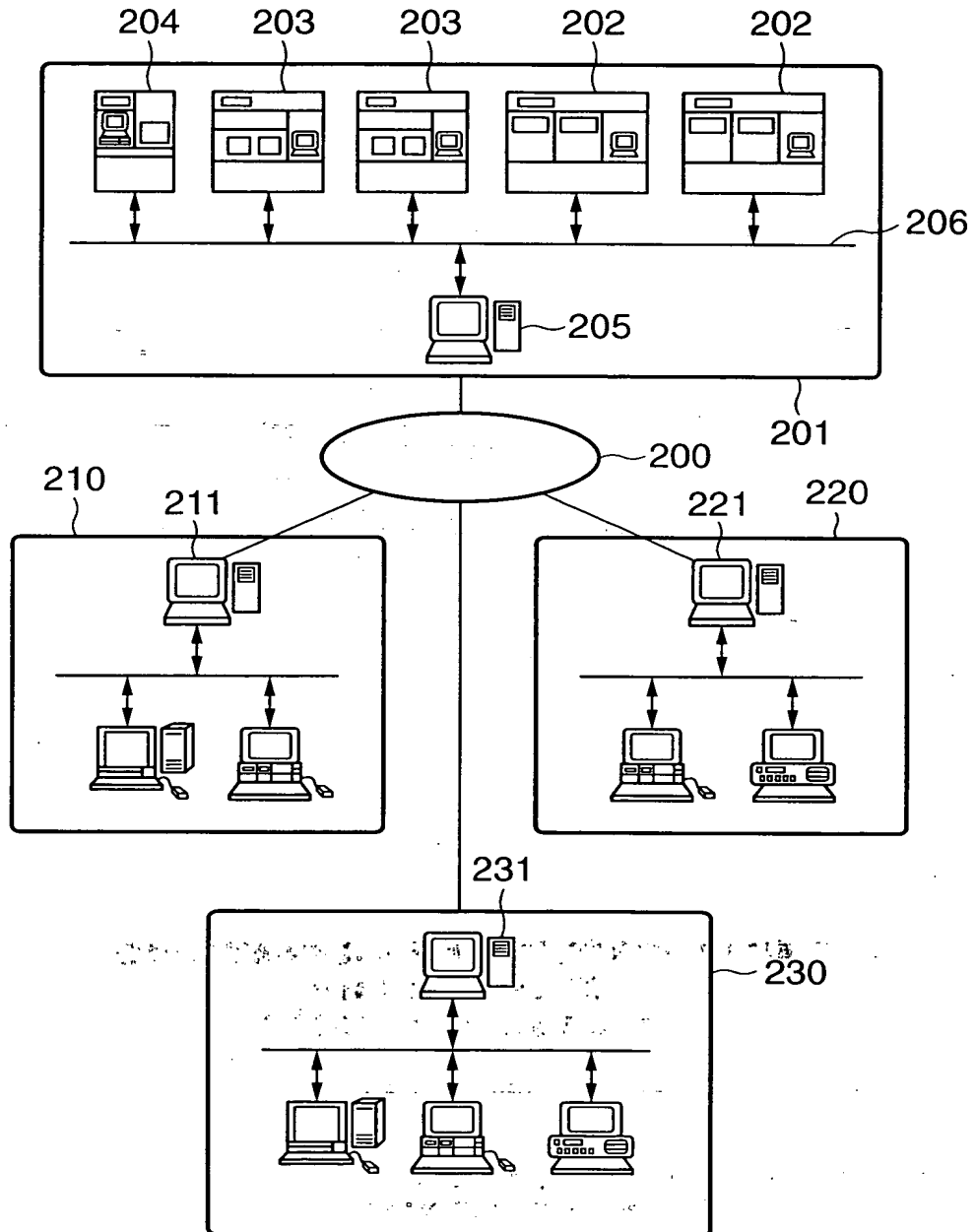


FIG. 10



URL

TROUBLE DB INPUT WINDOW

OCCURRENCE DATE  ~ 404

TYPE OF APPARATUS  ~ 401

SUBJECT  ~ 403

SERIAL NUMBER S/N  ~ 402

DEGREE OF URGENCY  ~ 405

SYMPTOM  ~ 406

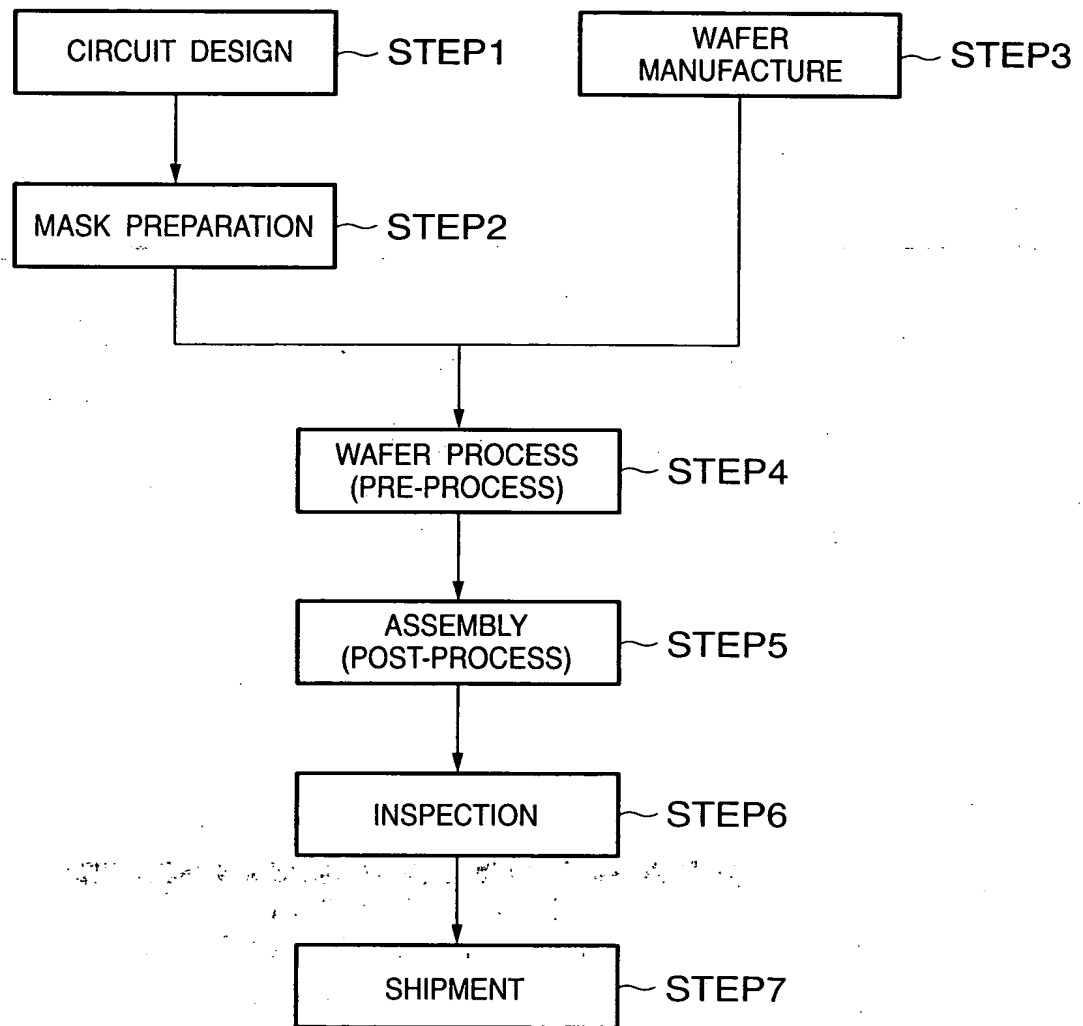
REMEDY  ~ 407

PROGRESS  ~ 408

~ 410 ~ 411 ~ 412

[LINK TO RESULT LIST DATABASE](#) [SOFTWARE LIBRARY](#) [OPERATION GUIDE](#)



**FIG. 12**

SEMICONDUCTOR DEVICE MANUFACTURING FLOW

FIG. 13

